

filed on 2/6/2007

KC
DC

Patent No.	Issue Date	First Named Inventor
6,101,164	2000-08-08	Kado

This filing is not intended to represent that the above listed patent, publications and articles are material to patentability as defined in 37 C.F.R. §1.56. Rather, Applicant does not believe that the listed patent, publications and articles affects the patentability of the claims in the above captioned application. However, Applicant offers that the references, though cumulative and not considered to be of particular relevance, may fall under the duty of disclosure; therefore, Applicant is filing this IDS. Applicant understands that the IDS will not be considered, but will be placed in the application file.

No fee is believed due in connection with this paper. However, the Commissioner is authorized to charge any underpayment or credit any overpayment to Deposit Account No. 06-1325 for any matter in connection with this response, including any fee for extension of time, which may be required.

Respectfully submitted,

Date: 02/06/2007

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Sheet 1 of 6

Form PTO-1449 (Substitute) DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				Attorney Docket Number LAZE-01000US0	Application/Patent Number 09/465,592		
<i>Information Disclosure Statement BY APPLICANT (Use several sheets if necessary)</i>				Applicant/Patent Owner Culver et al.			
				Filing/Issue Date 12/17/99	Group Art Unit 2653 2627		
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lc		5,166,919	11/24/92	Eigler et al.	369	126	07/11/91
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lc		5,264,876	11/23/93	Kawade et al.	346	153.1	01/19/93
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Examiner Initial	Application Number	Filing Date	First Named Inventor	Petition to Expunge? Yes No

PENDING U.S. PATENT APPLICATIONS

Examiner Initial		Application Number	Filing Date	First Named Inventor	Petition to Expunge? <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Publication Date	Country	Class	Subclass	Trans-lation <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No

OTHER DOCUMENTS (Include author (if any), title, publisher and place of publication, date and pertinent pages)

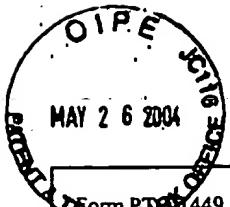
Examiner Kim Cim

Date Considered 2/21/2007

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

*1 = Copy not submitted because it was submitted in prior application SN /, filed , 20 , relied on under 35 USC §120.

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Sheet 1 of 4

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE (Substitute)	Attorney Docket Number LAZE-01000US0 SRM/MLR	Serial/Patent Number 09/465,592
Information Disclosure Statement BY APPLICANT (Use several sheets if necessary)		RECEIVE
		JUN 01 2004
		Technology Center 2000 2653 2627

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Examiner Initial		Patent Number	Issue Date	First Named Inventor	Class	Subclass	Filing Date
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lc	2	5,335,197	08/02/94	Kaneko et al.	365	153	12/10/91
lc	3	5,389,475	02/14/95	Yanagisawa et al.	430	019	06/18/92
lc	4	5,446,684	08/29/95	Kaneko et al.	365	046	05/10/94
lc	5	5,471,458	11/28/95	Oguchi et al.	369	126	09/08/93
lc	6	5,557,596	09/17/96	Gibson et al.	369	101	07/12/95
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lc	8	5,778,134	07/07/98	Sakai et al.	386	046	09/03/96
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Sheet 2 of 4

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Examiner Initial		Patent Application Publication Number	Publication Date	Applicant
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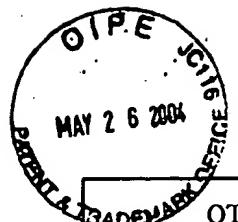
Examiner Initial		Application Number	Filing Date	First Named Inventor	Petition to Expunge? Yes No

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Examiner Initial		Document Number	Publication Date	Country	Class	Subclass	Trans-lation Yes No
lc	21	WO 96/11472	04/18/96	PCT			
lc	22	JP3295043	12/26/91	JAPAN			X
lc	23	JP3295044	12/26/91	JAPAN			X
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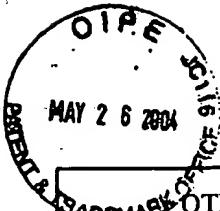
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Examiner	Klim Clark	
	Date Considered	2/21/2007
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